

Special Issue

Advances in Sensors and Electronic Instrumentation 2024

Message from the Guest Editors

After successful events in 2015 (Dubai, UAE), 2016 (Barcelona, Spain), 2017 (Moscow, Russia), 2018 (Amsterdam, the Netherlands), 2019 (Tenerife (Canary Islands), Spain), 2020 (Porto, Portugal), 2021 (Palma de Mallorca (Balearic Islands), Spain), 2022 (Corfu, Greece), and 2023 (Funchal (Madeira Island), Portugal), the SEIA' 2024 will take place in Ibiza (Balearic Islands) on 25–27 September 2024 in co-location with the [6th IFSA Frequency and Time Conference \(IFTC' 2024\)](#) and the [6th International Conference on Microelectronic Devices and Technologies \(MicDAT '2024\)](#) under the same conference umbrella in-person format. This Special Issue contains extended papers from SEIA' 2024 (<https://seia-conference.com/>) and MicDAT '2024 (<https://www.micdat-conference.com/>). In addition, submissions from others that are not associated with these two conferences but with themes focusing on sensors and electronic instrumentation are also welcome.

Guest Editors

Prof. Dr. Sergey Y. Yurish

International Frequency Sensor Association (IFSA), 08860 Castelldefels, Barcelona, Spain

Dr. Muhammad Ali Butt

Institute of Microelectronics and Optoelectronics, Warsaw University of Technology, 00-662 Warsaw, Poland

Deadline for manuscript submissions

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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

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